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Mail Stop AMENDMENT
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on December 18, 2007.

Michael S. Huppert

name of person signing certification

Michael S. Huppert

December 18, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 5135
Atuhito MOCHIDA et al. : Attorney Docket No. 2003_1798A
Serial No. 10/730,982 : Group Art Unit 1725
Filed December 10, 2003 : Examiner Kiley Shawn Stoner
A METHOD OF MOUNTING A **Mail Stop: AF**
SEMICONDUCTOR LASER
COMPONENT ON A SUBMOUNT

AMENDMENT AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 18, 2007, please amend the above-referenced U.S. patent application as follows: